

UNITED STATES DEPARTMENT OF COMMERCE

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ATTORNEY DOCKET NO. APPLICATION NO./ FILING DATE FIRST NAMED INVENTOR / CONTROL NO. PATENT IN REEXAMINATION 10826985 4/19/2004 LUO ET AL 2269-5565.1US (02-

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ART UNIT PAPER 2823 20090309

DATE MAILED:

Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner for Patents

The reply brief filed 12/17/2008 has been entered and considered. The application has been forwarded to the Board of Patent Appeals and Interferences for decision on the appeal.

/Matthew S. Smith/ Supervisory Patent Examiner, Art Unit 2823

/Jarrett J Stark/ Examiner, Art Unit 2823

OK TO ENTER: /JS/ (03/09/2009) CONSIDERED: /JS/ (03/09/2009)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

In re Application of:

Luo et al

Serial No.: 10/826,985

Filed: April 19, 2004

For: METHODS FOR FORMING PROTECTIVE LAYERS ON SEMICONDUCTOR DEVICE COMPONENTS SO AS TO REDUCE OR ELIMINATE THE OCCURENCE OF DELAMINATION THEREOF AND CRACKING THEREIN

Confirmation No.: 3493

Examiner: J. Stark

Group Art Unit: 2823

Attorney Docket No.: 2269-5565.1US

VIA ELECTRONIC FILING December 17, 2008

REPLY BRIEF

Mail Stop Appeal Brief – Patents Commissioner for Patents P.O. Box 1450 Alexandria. VA 22313-1450

Attn: Board of Patent Appeals and Interferences

Sirs:

This REPLY BRIEF follows the Examiner's Answer of October 17, 2008, and is being filed in accordance with the requirements of 37 C.F.R. § 41.41.